

Docket No.: 57810-032



PATENT

SP1768
JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Masayuki HATA, et al.	:	Confirmation Number: 2755
Application No.: 10/081,180	:	Group Art Unit: 1765
Filed: February 25, 2002	:	Examiner: Robert M. Kunemund
For: NITRIDE-BASED SEMICONDUCTOR ELEMENT AND METHOD OF FORMING NITRIDE-BASED SEMICONDUCTOR		

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action
dated May 20, 2004.